



AT
2/11/05
1
5

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Shun-ichi FUKUYAMA et al.

Group Art Unit: 2813

Serial No.: 10/630,716

Examiner: Stephen W. Smoot

Filed: July 31, 2003

Confirmation No.: 9374

For: SEMICONDUCTOR DEVICE USING LOW-K MATERIAL AS
INTERLAYER INSULATING FILM AND ITS MANUFACTURE
METHOD

Attorney Docket Number: 030860

Customer Number: 38834

RESPONSE AFTER FINAL

Box AF

Commissioner for Patents

P. O. Box 1450

Alexandria, VA 22313-1450

Date: April 20, 2005

Sir:

This paper is filed in response to the Office Action dated February 11, 2005.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 8 of this paper.

04/21/2005 HSL111 00000089 10530716
01 FC:1201 200.00 0P

O.K.
to
Enter
S.W.L.
5-2-05